

Atty. Dkt. No.  
33082W052

09/647659  
532 Rec'd PCT/PTC 04 OCT 2000

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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Applicant(s): Masahito OZAWA et al.

International PCT Application No.: PCT/JP99/01766

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Group Art Unit: To Be Assigned

Filed: : October 4, 2000 (Herewith)

Examiner: To Be Assigned

For : ALIGNMENT PROCESSING MECHANISM AND SEMICONDUCTOR  
PROCESSING UNIT WITH ALIGNMENT PROCESSING MECHANISM

**INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the documents cited in the International Search Report accompanying the national stage documents being filed on this same date together with a copy of each reference cited therein.

It is respectfully requested that each cited document be considered by the Examiner in the above-identified patent application and that each cited document be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Atty. Dkt. No.:  
33082W0502

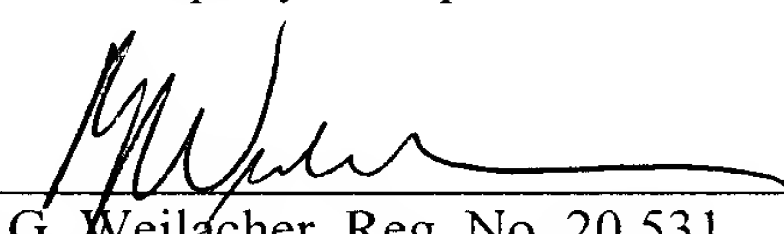
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This Information Disclosure Statement is being filed within three months of the filing date of the present application, and therefore it is believed that no fees are due under 37 C.F.R. Section 1.97(i).

Respectfully submitted,

SMITH, GAMBRELL & RUSSELL, LLP

Beveridge, DeGrandi, Weilacher & Young  
Intellectual Property Group

By:   
Robert G. Weilacher, Reg. No. 20,531  
1850 M Street, N.W., Suite 800  
Washington, D.C. 20036  
Telephone: (202) 659-2811  
Fax: (202) 659-1462

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